



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re patent application of

Takashi OGURA, et al.

Serial No.: 10/561,608 Group Art Unit: 2814
Filing Date: December 20, 2005 Examiner: Pham, Hoai V.
For: SEMICONDUCTOR DEVICE AND PRODUCTION METHOD THEREFOR

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

PETITION AND FEE FOR EXTENSION OF TIME
UNDER 37 C.F.R. §1.111

Sir:

Applicant hereby petitions for a one-month extension of time to respond to the First Office Action, Restriction Requirement, and Election of Species Requirement, dated January 17, 2007. A check for the extension fee in the amount of \$120.00 is attached. A duplicate copy of this sheet is enclosed.

The Commissioner is hereby authorized to charge any deficiencies in fees or to credit any overpayment of fees to Attorney's Deposit Account No. 50-0481.

Respectfully submitted,



Sean M. McGinn, Esq.
Registration No. 34,386

Date: 3/15/07

MCGINN INTELLECTUAL PROPERTY

LAW GROUP, PLLC
8321 Old Courthouse Road, Suite 200
Vienna, Virginia 22182-3817
(703) 761-4100
Customer No. 21254

03/16/2007 SZEWDIE1 00000053 10561608

01 FC:1251

120.00 0P